209291US0 Docket No.

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Hiroyuki NAGASAWA, et al.

SERIAL NO: 09/867,467

GAU:

1765

FILED:

May 31, 2001

EXAMINER: M. SONG

FOR:

METHOD OF MANUFACTURING SILICON CARBIDE, SILICON CARBIDE, COMPOSITE

MATERIAL, AND SEMICONDUCTOR ELEMENT

REQUEST FOR EXTENSION OF TIME UNDER 37 C.F.R. 1.136

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR:

It i	s hereby requested that a one month extension of time be granted to October 5, 2003 for
	filing a response to the Official Action dated:
	responding to the requirements in the Notice of Allowability dated:
	filing the Formal Drawings. The Issue Fee due has been timely filed.
	responding to the Notice to File Missing Parts of Application dated:
	filing a Notice of Appeal. A Request for Continued Examination (RCE) is being filed herewith.
	filing an Appeal Brief. A Notice of Appeal was filed on:
	Applicant claims small entity status. See 37 CFR 1.27. Therefore, the fee amount shown below is reduced by one-half.
The of I	e required fee of \$110.00 is enclosed herewith by check and any further charges may be made against the Attorney Record's Deposit Account No. <u>15-0030</u> . A duplicate copy of this sheet is enclosed.
SSES	Respectfully Submitted,
	10.00 00 ON SHIVAY MOCLELLAND

\$608\\$008

08 FC:1231

OBLON, SPIVAK, McCLELLAND, MAIER & NEUSTADT, P.C.

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